

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s):	William G. America, et al.	Examiner:	Jack S. J. Chen
Serial No:	10/674,646	Art Unit:	2813
Filed:	September 30, 2003	Docket:	YOR920030320US1 (16868)
For:	PLASMA SURFACE MODIFICATION AND PASSIVATION OF ORGANO- SILICATE GLASS FILMS FOR IMPROVED HARDMASK ADHESION AND OPTIMAL RIE PROCESSING	Dated:	July 29, 2008

Confirmation No. 4797

Commissioner for Patents
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RESPONSE UNDER 37 C.F.R. § 1.111


Sir:

In response to the Office Action dated June 30, 2008, Applicants submit the following amendments and remarks for entry of record in the above-identified patent application.

CERTIFICATE OF ELECTRONIC FILING

I hereby certify that this correspondence is being deposited with the United States Patent & Trademark Office via Electronic Filing through the United States Patent and Trademark Office e-business website on July 29, 2008.

Dated: July 29, 2008



Leslie S. Szivos, Ph.D.